



Attorney Docket No. 0756-7201

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Toru TAKAYAMA et al.

Serial No. 10/664,866

Filed: September 22, 2003

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE AND
HEAT TREATMENT METHOD

) Group Art Unit: 2818

) Examiner: Thao P. Le

) CERTIFICATE OF MAILING
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) Thao P. Le

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated March 5, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 13 of this paper and include an attached replacement sheet.

Remarks begin on page 14 of this paper.